

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Yoshihisa IBA**

Serial Number: **Not Yet Assigned**

Filed: **February 24, 2004**

Customer No.: 38834

For: **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

February 24, 2004


Sir:

In compliance with 37 CFR 1.56, Applicant(s) call(s) to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP


Scott M. Daniels
Reg.: 32,562

Atty. Docket No.: 042139
1250 Connecticut Avenue, N.W., Suite 700
Washington, D.C. 20036
Tele: (202) 822-1100
Fax: (202) 822-1111
SMD/ll
Enclosures: PTO-1449; References (4)

INFORMATION DISCLOSURE STATEMENT PTO-1449	Attv. Docket No. 042139	Serial No. New Appln.
	Applicant(s): Yoshihisa IBA	
	Filing Date: February 24, 2004	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA					
	AB					
	AC					
	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
AE 2003-124189	04/25/03	Japan	Abstract & Discussed in the Spec.
AF 3250518	11/16/01	Japan	Abstract & Discussed in the Spec.
AG 3365554	11/01/02	Japan	Abstract & Discussed in the Spec.
AH 2002-026121	01/25/02	Japan	Abstract & Discussed in the Spec.
AI			

OTHER DOCUMENTS

	AJ	
	AK	
Examiner	Date Considered	